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Session 2

Session Chair

**BiTS Workshop 2015 Schedule** 

## Frontiers Day

Monday March 16 1:30 pm

#### **Spanning the Socket Rainbow**

"Contacting Solutions for High Power Bare Die Testing (IGBT MOS-FET and Diodes)"

Markus Wagner - Cohu SEG

"Comparison of Different Methods in Determining Current Carrying Capacity of Semiconductor Test Contacts"

Valts Treibergs - Xcerra Corporation

"Are New Temperature Test Strategies Needed? Meeting Performance and Cost Requirements of Today's Applications"

Andreas Nagy - Xcerra Corporation

"Extreme Temperature and High Current Testing Challenges of Automotive Devices"

Praveen kumar Ramamoorthy & Murad Hudda - Infineon Technologies Dan Maccoux & Muhamad Izzat bin Roslee - JF Microtechnology

www.bitsworkshop.org



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# **Comparison of Different Methods in Determining Current Carrying Capacity of Semiconductor Test Contacts**

Valts Treibergs, Mitchell Nelson **Xcerra Corporation** 



2015 BiTS Workshop March 15 - 18, 2015

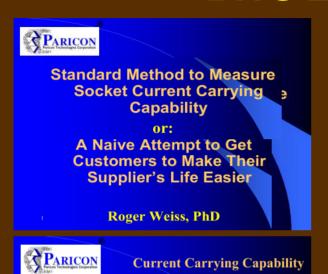


## **Presentation Agenda**

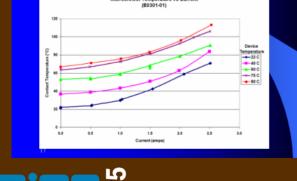
- Current Carrying Capacity (CCC) as discussed at BiTS, SWTW, and standards
  - Force relaxation method
  - IR Thermal imaging method
  - Thermocouple T-Rise method
- Example case study: CCC testing of a 0.3mm pitch spring probe
- Discussion and comparison of results is there a best method for BiTS interconnects?



### BiTS 2003 - Paricon

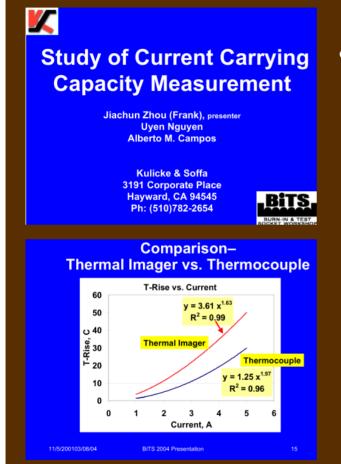


- No industry standards apply to power characterization of sockets
- Single thermocouple approach from PCB side of interconnect
- Emulates socket thermal environment



Interconnect Temperature vs Current

#### **BiTS 2004 – K&S**



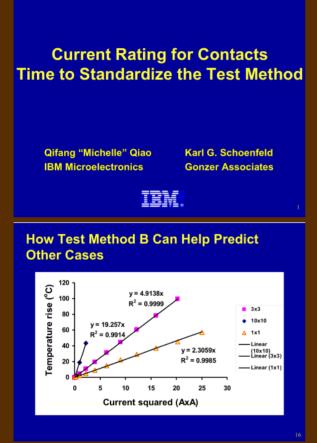
- Thermocouple T-Rise vs. IR Camera
  - Thermal Imager and thermocouple measurements generally agree – IR camera more repeatable and accurate
  - Thermocouple only 1-point measurement and act as heat-sink



Comparison of Different Methods in Determining Current Carrying Capacity of Semiconductor **Test Contacts** 

4

### **BiTS 2004 - IBM**



- 2-Step approach –
   characterize T-rise of
   single pin at ambient in
   air then of cluster of pins
- Develop model to predict socket performance
- Test based on EIA-364-70 standard



#### BiTS 2004 - Intel

**Socket Current Carrying Capacity** (CCC) Characterization

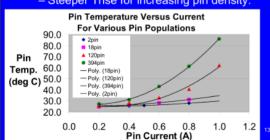
> Victor Henckel Glenn Cunningham Hongfei Yan



Intel Corporation

#### Test Result

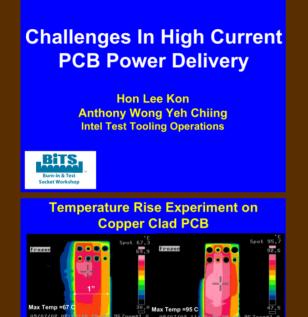
- Test performed at room temperature (23C).
- T<sub>pin</sub>, T<sub>substrate</sub>, and T<sub>pintail</sub> at current levels.
- Below is the T<sub>pin</sub> for various pin populations.
  - Steeper Trise for increasing pin density.



- One-pin thermocouple method not adequate
- Socket thermal environment must be taken into account
- Capability from socket suppliers needed to characterize entire socket CCC



#### BiTS 2004 - Intel



PCB Stackup do affect thermal dissipation

- Intel then further pushed the challenge into the PCB for power delivery
- Demonstrated the same methodology used in characterizing socket interconnects
- Introduced thermal simulation



Stackup A. 2 oz Cu at 70 A.

#### BiTS 2009 - Johnstech

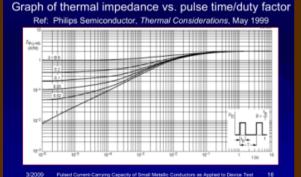
Pulsed Current-Carrying Capacity of Small Metallic Conductors as Applied to Device Test

Harlan Faller, P.E.
Johnstech International

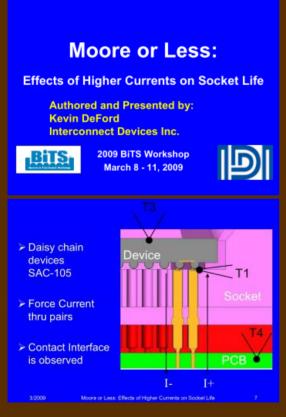
2009 BiTS Workshop
March 8 - 11, 2009

Transient Analysis

- Very useful tutorial in correlating pulsed current applications to steady-state
- Guidelines presented for pulsed current contact reliability, but no specific test method



#### **BiTS 2009 - IDI**



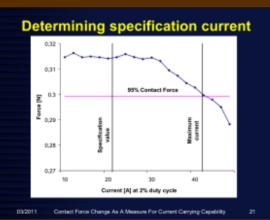
- Single-pin in air (thermocouple) method not adequate, but a good baseline
- Propose to introduce DUT metallic interface into the mix
   – simulate real world
- Intermetallics and electromigration degrade even CCC even more



#### **BiTS 2015**

#### **BiTS 2011 - Multitest**

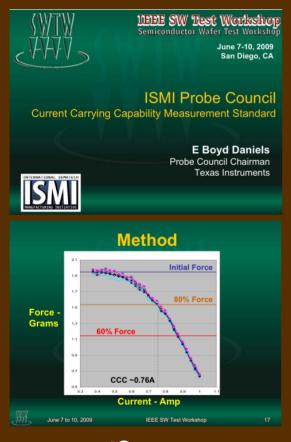




- Proposed and compared a loss of contact force in a cantelever-based contact due to joule heating
- Proved that method can be correllated with single-pin T-rise thermocouple method



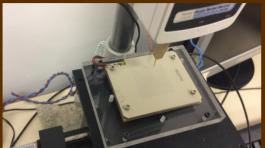
#### ISMI Probe Council CCC Measurement Guideline

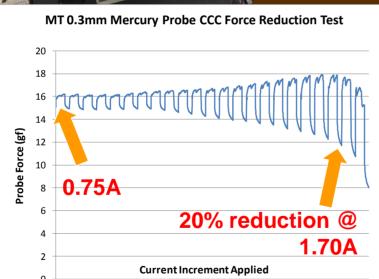


- Pub. 2009 from the MFGM042M project –and presented at SWTW 2009 for wafer probe CCC
  - Failure defined as 20% force reduction
  - DC current applied at nominal overdrive, then force is measured at room temp.
     after prescribed cool-down period
  - Test is stopped when probe force reduction reaches 40%
  - 30 probes are tested selected randomly
  - Is it useful for socket contacts one piece or assembled probes?



### **ISMI CCC Example: 0.3mm Spring Probe**



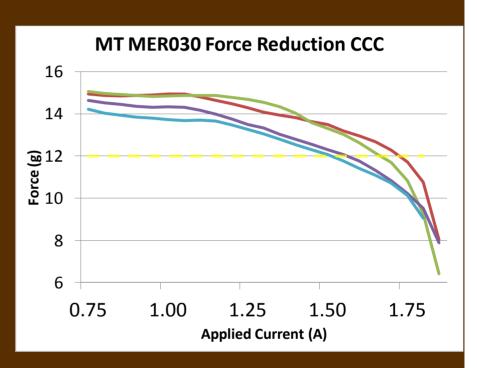


- Single probe placed in fixture
- Stage adjusted until nominal probe force achieved
- Each DC current increment applied for 2 min, 1min cool-down \*
- Looped until 40% reduction seen



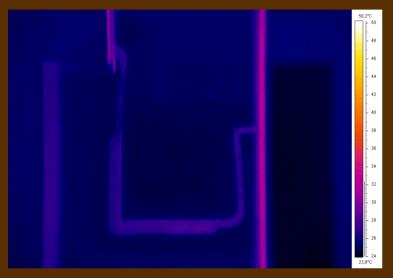
## **ISMI CCC Example: 0.3mm Spring Probe**

- Spring element in probe heats and expands – increasing probe force during power cycle
- Cool-down period is very long: 5-10 minutes required at higher currents.
  - Socket housing materials and cross-sections dissipate heat very slowly





## **Thermal Imaging CCC Method**



Example: pulsed current in MT high-power ecoAmp one-piece cantilever contact

- Sees thermal conduction in realtime – finds hot-spot
- Observe accumulating heat in socket housing



## **Thermal Imaging Example: 0.3mm Spring Probe**



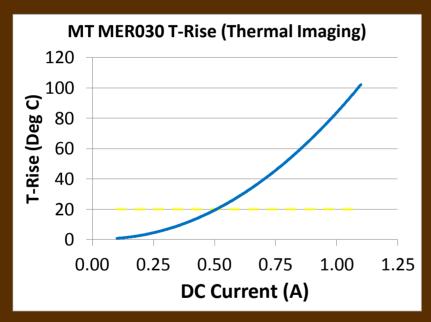
- FLIR P640 camera
- Custom PEEK fixture with exposed side
- Clamped to probe test height



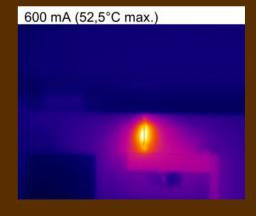




## **Thermal Imaging Example: 0.3mm Spring Probe**



- IR camera reported highest temperature
- Smooth data, but limited in resolution



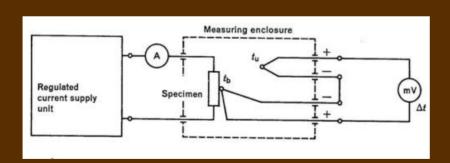


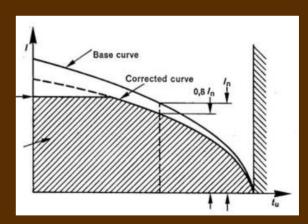
Comparison of Different Methods in Determining Current Carrying Capacity of Semiconductor **Test Contacts** 

16

## **Thermocouple T-Rise Method**

- IEC 60512-5-2 Test 5b
  - Standard test method to assess the CCC of electromechanical components (connectors) at elevated ambient temperature.
- EIA/ECA 364-70
  - Temperature rise versus current test procedure for electrical connectors and sockets



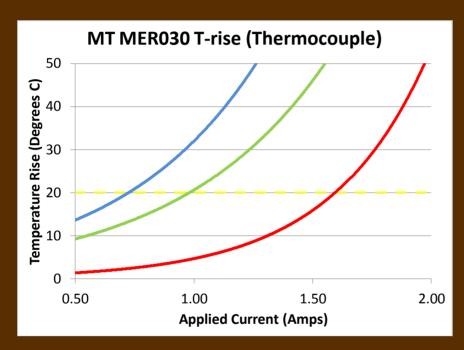




Comparison of Different Methods in Determining Current Carrying Capacity of Semiconductor Test Contacts

17

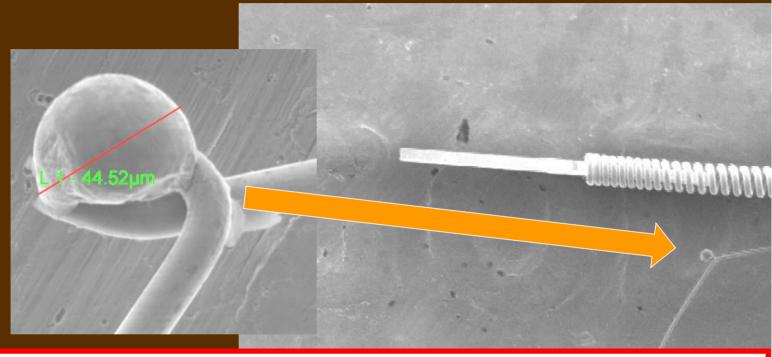
# Thermocouple Example: 0.3mm Spring Probe



- 3 test runs avg. 10 pins each
- Very high variability of results
- Thermocouple proximity to hotspots questionable



## **Thermocouple Insanity**



#### 2.1.3.1 Thermocouples

#### From EIA 364-70

In order to reduce heat sinking the cross sectional area of the thermocouple wire shall not exceed 50% of the cross sectional area of the contact(s) being measured.



Comparison of Different Methods in Determining Current Carrying Capacity of Semiconductor Test Contacts

19

## **Comparison & Discussion**

Thermocouple  •'Standard' methods  •Derating comples to the done in socket  ISMI Force- Reduction  •Can be done in socket housings •Long test to the done in socket housings •Long test to the done in socket housings •Thermal tenvironment tenuity to the done in socket housings •Thermal tenvironment tenuity t	
ISMI Force- housings •Long test to Reduction •Can be robotically automated – lights-out •Thermal environment of the statement of the Reduction •Can be robotically automated – lights-out	rve
•Resolution	
Modeling & •Learn about design in Simulation advance of hardware  •Model assum •Needs accu	rate



